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Implants for surgery — Metallic materials —

Part 7: Forgeable and cold-formed cobalt-chromium-nickel-molybdenum- iron alloy

~~Fourth edition~~

~~Date: 2024-01-15~~

~~*Implants chirurgicaux — Matériaux métalliques —*~~

~~*Partie 7: Alliage à forger mis en forme à froid à base de cobalt, de chrome, de nickel, de molybdène et de fer*~~

ISO/PRF 5832-7

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Foreword

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This document was prepared by Technical Committee ISO/TC 150, *Implants for surgery*, Subcommittee SC 1, *Materials*, in collaboration with the European Committee for Standardization (CEN) Technical Committee CEN/TC ###, *[name of committee]*, *285. Non-active surgical implants*, in accordance with the Agreement on technical cooperation between ISO and CEN (Vienna Agreement).

This fourth edition cancels and replaces the third **edition** (ISO 5832-7:2016), which has been technically revised.

The main changes are as follows:

- ~~introduction~~ introduction has been updated;
- ~~mechanical testing language~~ mechanical testing language has been updated;
- ~~this document harmonised to~~ **has been harmonized with the** ISO 5832 ~~-series~~.

A list of all parts in the ISO 5832 series can be found on the ISO website.

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